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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/806,031	03/22/2004	Koji Higuchi	9319A-000736	9984
27572 7590 04/05/2007 HARNESS, DICKEY & PIERCE, P.L.C. P.O. BOX 828			EXAMINER	
			UHLENHAKE, JASON S	
BLOOMFIELD HILLS, MI 48303			ART UNIT	PAPER NUMBER
			2853	
SHORTENED STATUTOR	Y PERIOD OF RESPONSE	MAIL DATE	DELIVERY MODE	
3 MO	NTHS	04/05/2007	PAPER	

Please find below and/or attached an Office communication concerning this application or proceeding.

If NO period for reply is specified above, the maximum statutory period will apply and will expire 6 MONTHS from the mailing date of this communication.

	Application No.	Applicant(s)	
	10/806,031	HIGUCHI ET AL.	
Office Action Summary	Examiner	Art Unit	
	Jason Uhlenhake	2853	
The MAILING DATE of this communication ap	pears on the cover sheet with the	correspondence address	
A SHORTENED STATUTORY PERIOD FOR REPL WHICHEVER IS LONGER, FROM THE MAILING D. Extensions of time may be available under the provisions of 37 CFR 1. after SIX (6) MONTHS from the mailing date of this communication. If NO period for reply is specified above, the maximum statutory period. Failure to reply within the set or extended period for reply will, by statut Any reply received by the Office later than three months after the mailin earned patent term adjustment. See 37 CFR 1.704(b).	DATE OF THIS COMMUNICATION 136(a). In no event, however, may a reply be to limit the series of the	N. imely filed m the mailing date of this communication. ED (35 U.S.C. § 133).	
Status			
1) Responsive to communication(s) filed on 22 L 2a) This action is FINAL . 2b) This 3) Since this application is in condition for allowed closed in accordance with the practice under	s action is non-final. ance except for formal matters, p		
Disposition of Claims	•		
4) ☐ Claim(s) 1,2,4-11 and 16-29 is/are pending in 4a) Of the above claim(s) is/are withdra 5) ☐ Claim(s) 1,2,4-11 and 16-27 is/are allowed. 6) ☐ Claim(s) 28 and 29 is/are rejected. 7) ☐ Claim(s) is/are objected to. 8) ☐ Claim(s) are subject to restriction and/or	awn from consideration.		
Application Papers			
9) The specification is objected to by the Examina 10) The drawing(s) filed on <u>02 August 2004</u> is/are: Applicant may not request that any objection to the Replacement drawing sheet(s) including the correct 11) The oath or declaration is objected to by the E	: a)⊠ accepted or b)⊡ objected e drawing(s) be held in abeyance. So ction is required if the drawing(s) is o	ee 37 CFR 1.85(a). bjected to. See 37 CFR 1.121(d).	
Priority under 35 U.S.C. § 119			
12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of: 1. Certified copies of the priority document 2. Certified copies of the priority document 3. Copies of the certified copies of the priority document application from the International Bureat * See the attached detailed Office action for a list	nts have been received. Its have been received in Applica Drity documents have been received (PCT Rule 17.2(a)).	tion Noved in this National Stage	
Attachment(s) 1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO/SB/08) Paper No(s)/Mail Date	4) Interview Summar Paper No(s)/Mail I 5) Notice of Informal 6) Other:	Date	

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DETAILED ACTION

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 28, 29 are rejected under 35 U.S.C. 103(a) as being unpatentable over Hirano (U.S. Pat. 5,731,826) in view of Fukano (JP 63-141750)

Hirano discloses:

- regarding claims 28, 29, droplet ejection apparatus having a driving circuit (54) (Column 19, Lines 3-7; 21-30) and a plurality of droplet ejection heads (Column 5, Lines 33-37)
- droplet ejection heads include a cavity (323d) filled with a liquid, a nozzle (323c) communicated with the cavity (Figures 6, 16A, 16B)
- ejection failure detecting and recovery processing determining means which detects a residual vibration of the diaphragm at least when the apparatus is powered on (Column 3, Lines 20 30; Column 7, Lines 32 40)
- recovery means for carrying out the recovery processing determined by the ejection failure detecting and recovery processing determining means (Column 10, Lines 60 67; Column 24, Lines 1 7)

Hirano does not disclose expressly the following:

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- regarding claim 28, the ejection failure detecting and recovery
processing determining means includes an oscillation circuit and the oscillation circuit
oscillates in response to an electric capacitance component that varies with the residual
vibration of the diaphragm

regarding claim 29, the ejection failure detecting and recovery processing determining means includes an oscillation circuit and the oscillation circuit oscillates in response to an electric capacitance component of the actuator that varies with the residual vibration of the diaphragm

Fukano discloses:

- regarding claim 28, the ejection failure detecting and recovery processing determining means (buffer, 3; transistors, 7&8; diode, 11; capacitor, 10; resistance 16-21; Figure 1; page 5, lines 14-16) includes an oscillation circuit (piezoelectric element, 9; resistance, 13&14; Figure 1; page 5, Lines 17-20) and the oscillation circuit oscillates in response to an electric capacitance component that varies with the residual vibration of the diaphragm (oscillating plate, 26) (page 5 line 21 page 6, line 16), for the purpose of detecting air bubbles in an ink chamber
- regarding claim 29, the ejection failure detecting and recovery processing determining means (buffer, 3; transistors, 7&8; diode, 11; capacitor, 10; resistance 16-21; Figure 1; page 5, lines 14-16) includes an oscillation circuit and the oscillation circuit (piezoelectric element, 9; resistance, 13&14; Figure 1; page 5, Lines 17-20) oscillates in response to an electric capacitance component of the actuator (9)

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that varies with the residual vibration of the diaphragm (oscillating plate, 26) (page 5 line 21 – page 6, line 16), for the purpose of detecting air bubbles in an ink chamber

At the time the invention was made it would have been obvious to a person of ordinary skill in the art to incorporate the teaching of Fukano into the device of Hirano, for the purpose of detecting air bubbles in an ink chamber

Response to Arguments

Applicant's arguments with respect to claims 1-29 have been considered but are moot in view of the new ground(s) of rejection.

Allowable Subject Matter

Claims 1-2, 4-11, and 16-27 are allowed.

The primary reason for the allowance of claims 1-2, 4-11, and 16-27 is the inclusion of the limitation of a droplet ejection apparatus including judging means judges that paper dust is adhering in the vicinity of the outlet of the nozzle in the case where the cycle of the residual vibration of the diaphragm is longer than the predetermined rage of cycle and shorter than the predetermined threshold. It is this limitation found in each of the claims, as it is claimed in the combination, that has not been found, taught or suggested by the prior art of record which makes these claims allowable over the prior art.

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Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Jason Uhlenhake whose telephone number is (571) .

272-5916. The examiner can normally be reached on Monday - Friday 8-5.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Stephen Meier can be reached on (571) 272-2149. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

March 31, 2007

STEPHEN MEIER SUPERVISORY PATENT EXAMINER